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# INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Sheet 1 of 2

## Complete if Known

Application Number	Not Yet Assigned
Filing Date	Herewith
First Named Inventor	Moeckley et al.
Group Art Unit	Not Yet Assigned
Examiner Name	Not Yet Assigned
Attorney Docket Number	844,004-303

Examiner Initials *	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY
	Number	Kind Code <sup>2</sup> (if known)		
KMV	6,294,025		Kinder	05/14/1998
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	6,626,995		Kim et al.	09/30/2003
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	2002/0127437		Cheong et al.	09/12/2002
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	2002/0173428		Thieme et al.	11/21/2002
	2003/0096710		Dunand	05/22/2003
	2003/0096711		Saito et al.	05/22/2003
	2003/0099871		Finnemore et al.	05/29/2003
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Examiner Initials *	Foreign Patent Document			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	T <sub>6</sub>
	Office <sup>3</sup>	Number <sup>4</sup>	Kind Code <sup>5</sup> (if known)			

Examiner Initials *	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T <sup>2</sup>
KMV	Brinkman, A. et al., "Superconducting Thin Films of MgB <sub>2</sub> on Si by Pulsed Laser Deposition", Physica C 353 (2001), pp 1-4	
	Bu, S.D. et al., "Synthesis and Properties of c-axis Oriented Epitaxial MgB <sub>2</sub> Thin Films", Appl. Phys. Lett., Vol. 81, No. 10, pp 1851-53, 2002	
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	Liu, Z. et al., "Thermodynamics of the Mg-B System: Implications for the Deposition of MgB <sub>2</sub> Thin Films", Applied Physics Letters, Vol. 78, No. 23, 4 June 2001, pp 3678-80	
	Nagomatsu, J. et al., "Superconductivity at 39K in Magnesium Diboride", Nature, Vol. 410, 1 March 2001, pp 63-64	
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	Zeng, X. et al., "In Situ Epitaxial MgB <sub>2</sub> Thin Films for Superconducting Electronics", Nature Materials, Vol. 1, September, 2002, pp 1-4	

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## INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Application Number	Not Yet Assigned
Filing Date	Herewith
First Named Inventor	Moeckley et al.
Group Art Unit	Not Yet Assigned
Examiner Name	Not Yet Assigned
Attorney Docket Number	844,004-303

Examiner  
Signature

/Kallambella Vijayakumar/

Date  
Considered

08/08/2006

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## INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Sheet 1 of 1

### Complete if Known

Application Number	10/726,232
Filing Date	December 1, 2003
First Named Inventor	Brian Moeckly et al.
Group Art Unit	1765
Examiner Name	Not Yet Assigned
Attorney Docket Number	844004-303

Examiner Initials *	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY
	Number	Kind Code <sup>2</sup> (if known)		
KMV	US-4,420,385		Hartsough	12/13/1983

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	Office <sup>3</sup>	Number <sup>4</sup>	Kind Code <sup>5</sup> (if known)			

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Examiner Signature	/Kallambella Vijayakumar	Date Considered	08/08/2006
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